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Surface chemical analysis — Vocabulary —

Part 2: Terms used in scanning-probe microscopy

Analyse chimique des surfaces — Vocabulaire —

Partie 2: Termes utilisés en microscopie à sonde à balayage

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Foreword

ISO (the International Organization for Standardization) is a worldwide federation of national standards bodies (ISO member bodies). The work of preparing International Standards is normally carried out through ISO technical committees. Each member body interested in a subject for which a technical committee has been established has the right to be represented on that committee. International organizations, governmental and non-governmental, in liaison with ISO, also take part in the work. ISO collaborates closely with the International Electrotechnical Commission (IEC) on all matters of electrotechnical standardization.

The procedures used to develop this document and those intended for its further maintenance are described in the ISO/IEC Directives, Part 1. In particular, the different approval criteria needed for the different types of ISO documents should be noted. This document was drafted in accordance with the editorial rules of the ISO/IEC Directives, Part 2 (see www.iso.org/directives).

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For an explanation of the voluntary nature of standards, the meaning of ISO specific terms and expressions related to conformity assessment, as well as information about ISO's adherence to the World Trade Organization (WTO) principles in the Technical Barriers to Trade (TBT), see www.iso.org/iso/foreword.html.

This document was prepared by Technical Committee ISO/TC 201, *Surface chemical analysis*, Subcommittee SC 1, *Terminology*.

This third edition cancels and replaces the second edition (ISO 18115-2:2013), of which it constitutes a minor revision.

The changes to the previous edition are as follows:

— the term "Kelvin-force microscopy" has been replaced with "Kelvin-probe force microscopy" and, where it occurred, the term "scanning-probe microscopy" has been replaced with "scanning probe microscopy".

A list of all parts in the ISO 18115 series can be found on the ISO website.

Any feedback or questions on this document should be directed to the user’s national standards body. A complete listing of these bodies can be found at www.iso.org/members.html.

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Introduction

Surface chemical analysis is an important area which involves interactions between people with different backgrounds and from different fields. Those conducting surface chemical analysis might be materials scientists, chemists, or physicists and might have a background that is primarily experimental or primarily theoretical. Those making use of the surface chemical data extend beyond this group into other disciplines.

With the present techniques of surface chemical analysis, compositional information is obtained for regions close to a surface (generally within 20 nm) and composition-versus-depth information is obtained with surface analytical techniques as surface layers are removed. The terms covered in this document relate to scanning probe microscopy. The surface analytical terms covered in ISO 18115-1 extend from the techniques of electron spectroscopy and mass spectrometry to optical spectrometry and X-ray analysis. Concepts for these techniques derive from disciplines as widely ranging as nuclear physics and radiation science to physical chemistry and optics.

The wide range of disciplines and the individualities of national usages have led to different meanings being attributed to particular terms and, again, different terms being used to describe the same concept. To avoid the consequent misunderstandings and to facilitate the exchange of information, it is essential to clarify the concepts, to establish the correct terms for use, and to establish their definitions.

The terms are given in alphabetical order, classified under the following:

— Clause 3: Definitions of the scanning probe microscopy methods;

— Clause 4: Acronyms and terms for contact mechanics models;

— Clause 5: Definitions of terms for scanning probe methods;

— Clause 6: Definitions of supplementary scanning probe microscopy methods;

— Clause 7: Definitions of supplementary terms for scanning probe methods.

In the terms in Clause 3, note that the final “M” or final “S” in the acronyms, given as “microscopy” or “spectroscopy”, may also mean “microscope” or “spectrometer”, respectively, depending on the context. For the definition relating to the microscope or spectrometer, replace the words “a method” by the words “an instrument” where that appears.

In contact mechanics, covered in Clause 4, the basic theories are often referenced by acronyms. To avoid confusion, these acronyms are defined below. These models all assume that the materials in contact are homogeneous and isotropic, and have a linear elastic constitutive behaviour. Various contact models for inhomogeneous, anisotropic, nonlinear, viscoelastic, elastoplastic, and other materials have been derived and can be found in the literature.

Many terms concerned with profilometry, or more correctly, surface texture measuring instruments, may be found in ISO 3274 and ISO 4287. ISO 3274 specifies the properties of the instrument that influence profile evaluation and provides basic considerations of the specification of contact (stylus) instruments (profile meter and profile recorder) whereas ISO 4287 concerns some issues involving surface texture.

Those interested in a more detailed understanding of profilometry or surface texture measuring instruments should consult ISO 3274, ISO 4287, ISO 25178 and other referenced documents.

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Surface chemical analysis — Vocabulary —

Part 2: Terms used in scanning-probe microscopy

1 Scope

This document defines terms for surface chemical analysis. ISO 18115-1 covers general terms and those used in spectroscopy while this document covers terms used in scanning probe microscopy.

2 Normative references

There are no normative references in this document.

3 Terms and definitions

ISO and IEC maintain terminological databases for use in standardization at the following addresses:

— ISO Online browsing platform: available at https://www.iso.org/obp

— IEC Electropedia: available at https://www.electropedia.org/

3.1 Terms related to scanning probe microscopy methods

3.1.1
apertureless Raman microscopy
<NSOM, SNOM> method of microscopy involving the acquisition of Raman spectroscopic data utilizing a *near-field* (5.88) optical source and based upon a metal *tip* (5.120) in close proximity to the sample surface illuminated with suitably polarized light

3.1.2
atomic-force microscopy
AFM
DEPRECATED: scanning force microscopy
DEPRECATED: SFM
method for imaging surfaces by mechanically scanning their surface contours, in which the deflection of a sharp *tip* (5.120) sensing the surface forces, mounted on a compliant *cantilever* (5.18), is monitored

Note 1 to entry: AFM can provide a quantitative height *image* (5.69) of both insulating and conducting surfaces.

Note 2 to entry: Some AFM instruments move the sample in the *x*-, *y*- and *z*-directions while keeping the tip position constant and others move the tip while keeping the sample position constant.

Note 3 to entry: AFM can be conducted in vacuum, a liquid, a controlled atmosphere, or air. Atomic resolution may be attainable with suitable samples, with sharp tips, and by using an appropriate imaging mode.

Note 4 to entry: Many types of force can be measured, such as the *normal forces* (5.91) or the *lateral* (5.77), *friction* (5.62), or shear force. When the latter is measured, the technique is referred to as *lateral* (3.1.13), *frictional* (3.1.11), or *shear force microscopy* (3.1.37). This generic term encompasses all of the types of force microscopy listed in Annex A.

Note 5 to entry: AFMs can be used to measure surface normal forces at individual points in the pixel array used for imaging.

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